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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/790,212	03/02/2004	Junichi Tanaka	500.43597X00	1013
20457 75	590 07/12/2006		EXAM	INER
	, TERRY, STOUT & K	KACKAR, RAM N		
1300 NORTH SEVENTEENTH STREET SUITE 1800		ART UNIT	PAPER NUMBER	
ARLINGTON,	VA 22209-3873		1763	
			DATE MAILED: 07/12/2000	5

Please find below and/or attached an Office communication concerning this application or proceeding.

				1
		Application No.	Applicant(s)	
		10/790,212	TANAKA ET AL.	
	Office Action Summary	Examiner	Art Unit	
		Ram N. Kackar	1763	
Period fo	The MAILING DATE of this communication ap or Reply	ppears on the cover she	eet with the correspondence ac	idress
WHIC - Exter after - If NO - Failu Any r	ORTENED STATUTORY PERIOD FOR REP CHEVER IS LONGER, FROM THE MAILING Insions of time may be available under the provisions of 37 CFR 1 SIX (6) MONTHS from the mailing date of this communication. In period for reply is specified above, the maximum statutory perior re to reply within the set or extended period for reply will, by statute eply received by the Office later than three months after the mailined patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMN. 136(a). In no event, however, it will apply and will expire SIX (it te, cause the application to become	MUNICATION.  may a reply be timely filed  by MONTHS from the mailing date of this come ABANDONED (35 U.S.C. § 133).	
Status				
2a) <u></u>	Responsive to communication(s) filed on 19.7 This action is <b>FINAL</b> . 2b)⊠ Th Since this application is in condition for allows	is action is non-final.	matters, prosecution as to the	e merits is
	closed in accordance with the practice under	Ex parte Quayle, 1935	5 C.D. 11, 453 O.G. 213.	
Dispositi	on of Claims			
5)□ 6)⊠ 7)□ 8)□ <b>Applicati</b> 9)□	Claim(s) 1-9 is/are pending in the application.  4a) Of the above claim(s) 7-9 is/are withdrawn  Claim(s) is/are allowed.  Claim(s) 1-6 is/are rejected.  Claim(s) is/are objected to.  Claim(s) are subject to restriction and/  on Papers  The specification is objected to by the Examin  The drawing(s) filed on is/are: a) accomplicated to the correct of the	n from consideration.  or election requirement  er.  cepted or b) □ objecte  drawing(s) be held in al	ed to by the Examiner. Deyance. See 37 CFR 1.85(a).	
11)[	The oath or declaration is objected to by the E			
	nder 35 U.S.C. § 119			, , , , , , , , , , , , , , , , , , , ,
12)⊠ <i>i</i> a)[	Acknowledgment is made of a claim for foreign  All b) Some * c) None of:  1. Certified copies of the priority document  2. Certified copies of the priority document  3. Copies of the certified copies of the priority application from the International Bureatee the attached detailed Office action for a list	ts have been received ts have been received prity documents have t au (PCT Rule 17.2(a)).	in Application No  Deen received in this National	Stage
Attachment	(s) e of References Cited (PTO-892)	م∏ احد	inu Summer (DTO 160)	
2) 🔲 Notice 3) 🔀 Inform	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948) nation Disclosure Statement(s) (PTO-1449 or PTO/SB/08 No(s)/Mail Date 3/2104	Pape	view Summary (PTO-413) r No(s)/Mail Date e of Informal Patent Application (PTC ::	)-152)

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## **DETAILED ACTION**

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## Election/Restrictions

1. Applicant's election with traverse of claims 1-6 in the reply filed on 4/19/2006 is acknowledged. The traversal is on the ground(s) that the features of the two groups are coextensive is not a valid reason for traversal. The distinction between the two groups has been adequately explained in the requirement of restriction.

The requirement is still deemed proper and is therefore made FINAL.

## Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 1-6 are rejected under 35 U.S.C. 103(a) as being unpatentable over Kagoshima et al (US Pub 2003/0003607) in view of an Article " Modeling the impact of photoresist trim etch process on photoresist surface roughness" by Shahid Rauf et al.

Kagoshima et al disclose an etching apparatus for etching of mask features (Fig 1 and Abstract) with plasma and a plasma monitor (3) to monitor the species in the plasma. Kagoshima teaches optimum recipe calculation model which depends upon the monitored result from the plasma monitor (24) that the measurement of CD (22).

Kagoshima et al fail to disclose the roughness parameter of the resist and its impact on the recipe calculation model.

Shahid Rauf et al have extensively studied dependence of etch rate upon roughness when all other factors remain same. They teach that the etch rate is high at the beginning if the initial roughness is high, and reduces when the roughness is reduced. So that it is essential to know the initial roughness in order to estimate etch time needed to etch to target CD. Shahid Rauf et al teach that the roughness factor (RF) is measured as in Fig 1 by R profile of the roughness part and the spatial frequency computed using Fourier transform (Page 656 Col 2).

Therefore it would have been obvious for one of ordinary skill in the art at the time of invention to provide to the optimum recipe calculation model of Kagoshima et al, not only the monitored result of the plasma monitor and the measured CD, but the initial roughness (RF) of the mask in order to deal with the effect of roughness on recipe time.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Ram N. Kackar whose telephone number is 571 272 1436. The examiner can normally be reached on M-F 8:00 A.M to 5:P.M.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Parviz Hassanzadeh can be reached on 571 272 1435. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <a href="http://pair-direct.uspto.gov">http://pair-direct.uspto.gov</a>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Ram Kackar

Primary Examiner AU 1763